

Docket No.: 071971-0432

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Satoshi SHIBATA :
Application No.: Not yet assigned : Group Art Unit: Not yet assigned
Filed: November 21, 2005 : Examiner: Not yet assigned
For: MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE

PRELIMINARY AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks / Arguments begin on page 3 of this paper.